

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q85504

Heiji WATANABE, et al.

Application No.: 10/519,084

Confirmation No.: 7332

Group Art Unit: 2822

Filed: December 23, 2004

Examiner: Tsz K. CHIU

For: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

**SUPPLEMENTARY AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

The present Amendment supplements the Amendment under 37 C.F.R. §1.116 filed May 29, 2008 and entered concurrently with a Request for Continued Examination submitted herewith. In response to the Advisory Action dated June 30, 2008, please amend the above-identified application as follows on the accompanying pages.

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